

# CURRICULUM VITAE

FRANZISKA C. BEYER

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## ADDRESS

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## PERSONAL DETAILS

Birth name: Täschner  
Date of birth: July 15, 1980  
Place of birth: Dresden, Germany  
Family status: married, 3 daughters  
Citizenship: German

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## EDUCATION

- 04/2006–10/2011 Semiconductor Materials Group, Department of Physics, Chemistry and Biology, Linköping University: PhD thesis:  
"Deep levels in SiC"
- 10/2000–03/2006 TU Bergakademie Freiberg, course of studies:  
"Angewandte Naturwissenschaft" (Applied Natural Science)  
Specialization: "Naturwissenschaftliche Grundlagen: Stoffe der Mikroelektronik"  
(Scientific Principles: Materials for Microelectronics)
- 09/1998–07/2000 Grammar school: Vitzthumgymnasium Dresden, Germany
- 09/1997–06/1998 Grammar school: Lycée International des Pontonniers, Strasbourg, France

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## SCIENTIFIC WORK

- 10/2015– Institute of Applied Physics, TU Bergakademie Freiberg, Germany:  
young researcher group: "Defekt-Engineering in wide band gap semiconductors  
for applications in opto and power electronics"
- 01/2012–09/2015 Institute of Applied Physics, TU Bergakademie Freiberg, Germany: PostDoc
- 11/2011–12/2012 Semiconductor Materials Group, Department of Physics, Chemistry and Biology, Linköping University, Sweden: PostDoc

- 04/2006–10/2011 PhD studies in Semiconductor Materials group, Department of Physics, Chemistry and Biology, Linköping University, Sweden:  
*Electrical characterization of deep levels in silicon carbide.*
- 08/2005–01/2006 Institute of Experimental Physics, TU Bergakademie Freiberg, Germany  
diploma thesis on *Characterisation of deep traps in organic semiconductors, Installation of a new setup and first results*
- 04/2004–09/2004 Institute of Experimental Physics, TU Bergakademie Freiberg, Germany  
student research project on *Realisation of TSC measurements for organic semiconductors*
- 07/2001–08/2001 Zentrum Mikroelektronik Dresden, ZMD, Germany  
physics internship in the group of photolithography
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## EXPERTISE

- Defect characterization:
    - CV - IV characteristics (Capacitance-voltage and Current-voltage characteristics)
    - DLTS (Deep level transient spectroscopy)
    - MCTS (Minority Carrier Transient Spectroscopy)
  - Sample preparation
    - chemical cleaning and HF-etching
    - electrical contact formation by thermal evaporation or sputtering, (e-beam evaporation)
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## PUBLICATIONS

- 33 (HIRSCH-index  $\approx$  9)
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## JOURNAL ARTICLES

- [1] **F. C. Beyer**, C. G. Hemmingsson, S. Leone, Y.-C. Lin, A. Gällström, A. Henry, and E. Janzén. Deep levels in iron doped n- and p-type 4H-SiC. *J. Appl. Phys.*, 110:123701, 2011.
- [2] **F. C. Beyer**, C. Hemmingsson, H. Pedersen, A. Henry, J. Isoya, N. Morishita, T. Ohshima, and E. Janzén. Annealing behavior of the EB-centers and M-center in low-energy electron irradiated n-type 4H-SiC. *J. Appl. Phys.*, 109:103703, 2011.
- [3] **F. C. Beyer**, C. G. Hemmingsson, A. Gällström, S. Leone, H. Pedersen, A. Henry, and E. Janzén. Deep levels in tungsten doped n-type 3C-SiC. *Appl. Phys. Lett.*, 98:152104, 2011.
- [4] S. Leone, **F. C. Beyer**, H. Pedersen, S. Andersson, A. Henry, O. Kordina, and E. Janzén. Chlorinated precursors study in low-temperature CVD of 4H-SiC. *Thin Solid Films*, 519:3074–3080, 2011.
- [5] **F. C. Beyer**, C. G. Hemmingsson, H. Pedersen, A. Henry, J. Isoya, N. Morishita, T. Ohshima, and E. Janzén. Capacitance transient study of a bistable deep level in e<sup>-</sup>-irradiated n-type 4H-SiC. *J. Phys. D: Appl. Phys.*, 45:455301, 2012.

- [6] Ian D. Booker, Jawad Ul Hassan, Louise Lilja, **F. C. Beyer**, Robin Karhu, J. Peder Bergman, Örjan Danielsson, Olof Kordina, Einar Ö. Sveinbjörnsson, and Erik Janzén. Carrier Lifetime Controlling Defects  $Z_{1/2}$  and RB1 in Standard and Chlorinated Chemistry Grown 4H-SiC. *Crystal Growth & Design*, 14(8):4104–4110, Aug 2014.
- [7] Patrick Hofmann, Christian Röder, Frank Habel, Gunnar Leibiger, **F. C. Beyer**, Günter Gärtner, Stefan Eichler, and Thomas Mikolajick. Silicon doping of HVPE GaN bulk-crystals avoiding tensile strain generation. *J. Phys. D: Appl. Phys.*, 49(7):075502, 2016.
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## REFERENCE

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(head of *Institute of Applied Physics*)  
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Freiberg, November 2, 2016